

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination KIRKER ET AL.	
		Examiner David A Reifsnyder	Art Unit 1723	Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-			
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E	US-			
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N	JP 2001113204 A	04-2001	Japan	WATANABE, SHINICHI	B04B 01/02
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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)	
U	English Abstract from the Patent Abstracts of Japan along with a Machine Translation of the rest of the specification of Japanese Patent Publication No. JP 2001113204 A . JP 2001113204 A was published on 04-2001.	
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